

<b>Notice of References Cited</b>	Application/Control No. 10/825,109	Applicant(s)/Patent Under Reexamination CHEN, MEI-LI	
	Examiner John Rivell	Art Unit 3753	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,967,184	10-1999	Chang, Chia-Bo	137/625.17
*	B	US-6,170,523	01-2001	Chang, Chia-Bo	137/625.17
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
	W	
	X	

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